

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
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<b>Attorney Docket Number</b>	51545/P849
<b>Application Number</b>	10/718,478
<b>Filing Date</b>	November 18, 2003
<b>Applicant(s)</b>	Jin-Sung Kim, et al.
<b>Group Art Unit</b>	1795
<b>Examiner Name</b>	Robert W. Hodge

**U.S. PATENT DOCUMENTS**

EXAMINER INITIALS	Cite No. <sup>1</sup>	DOCUMENT NUMBER Number - Kind Code <sup>2</sup> (If Known)	PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE
		5,580,680	12-03-1996	Chaloner-Gill et al.
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**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIALS	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (If Known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T <sup>6</sup> ( <input checked="" type="checkbox"/> )
		JP 7-176323	07-14-1995	Kubota	Patent Abstracts of Japan
		JP 7-320779	12-08-1995	Yamazaki et al.	Patent Abstracts of Japan
		JP 8-321312	12-03-1996	Jinno et al.	Patent Abstracts of Japan
		JP 10-189044	07-21-1998	Komaru, et al.	Patent Abstracts of Japan
		JP 11-329496	11-30-1999	Hayashi, et al.	Patent Abstracts of Japan
		JP 2000-106209	04-11-2000	Hayashi, et al.	Patent Abstracts of Japan
		JP 2001-223024	08-17-2001	Kin, et al.	Patent Abstracts of Japan
		WO 99/28987	06-10-1999	Narang, et al.	

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<b>Group Art Unit</b>	1795
<b>Examiner Name</b>	Robert W. Hodge

**OTHER DOCUMENTS**

EXAMINER INITIALS	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		Patent Abstracts of Japan, Publication No. 07-176323; Date of Publication: 07-14-1995; in the name of Shuji Kubota
		Patent Abstracts of Japan, Publication No. 07-320779; Date of Publication: 12-08-1995; in the name of Mikiya Yamazaki, et al.
		Patent Abstracts of Japan, Publication No. 08-321312; Date of Publication: 12-03-1996; in the name of Maruo Jinno, et al.
		Patent Abstracts of Japan, Publication No. 10-189044; Date of Publication: 07-21-1998; in the name of Tokuei Komaru, et al.
		Patent Abstracts of Japan, Publication No. 11-329496; Date of Publication: 11-30-1999; in the name of Takashi Hayashi, et al.
		Patent Abstracts of Japan, Publication No. 2000-106209; Date of Publication: 04-11-2000; in the name of Takashi Hayashi, et al.
		Patent Abstracts of Japan, Publication No. 2001-223024; Date of Publication: 08-17-2001; in the name of Chinsei Kin, et al.

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